

**METHOD AND APPARATUS FOR MOISTENING CLEANROOM
WIPERS**

ABSTRACT OF THE DISCLOSURE

A device for uniform moistening of cleanroom wipers. The device
10 includes a wetting chamber where nozzles are directed toward wipers placed on a
rack. A liquid supply and a pump with a user interface are connected to the wetting
chamber. A pump control in conjunction with a feedback device regulates the
amount of liquid dispensed to the wipers to meet a target saturation level as
inputted into the user interface. The saturation level of the wipers are monitored by
15 one of several parameters which include time, mass, conductivity or pressure.